

GAV 1746



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Atty Docket No. SCP-5020

In re Patent Application of: Tamer Elsayy et al.

Application No.: 09/905,025

Filed: July 13, 2001

For: VAPOR DRYING SYSTEM AND METHOD

Commissioner for Patents
Washington, D.C. 20231

Sir:

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Transmitted herewith is an Information Disclosure Statement and PTO-1449 in the above-identified application.

1. ☐ No additional fee is required.
2. ☐ A check in the amount of \$_____ is attached.
3. ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. [Client No.]SCP-5020.
A duplicate copy of this sheet is enclosed.
4. ☐ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

Dated:

21 September 2001

By:

Kathleen A. Frost

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on September 21, 2001.

Dated: 09/21/01

By:

Judith Cotham
Judith Cotham